



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

June 23, 2026

IGI Report Number

Description

Shape and Cutting Style

Measurements

LG811649083

LABORATORY GROWN DIAMOND

ROUND BRILLIANT

6.53 - 6.56 X 3.96 MM

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

Cut Grade

1.03 CARAT

D

VVS 1

IDEAL

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

Inscription(s)

EXCELLENT

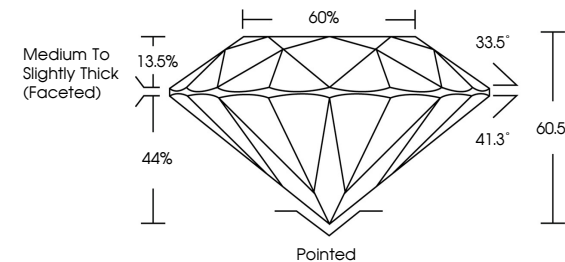
EXCELLENT

NONE

IGI LG811649083

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

PROPORTIONS



Medium To Slightly Thick (Faceted)

60%

33.5°

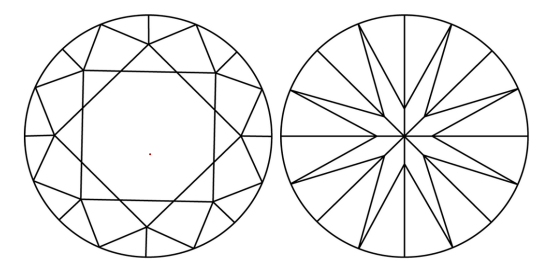
41.3°

60.5%

44%

Pointed

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

COLOR

D

E

F

G

H

I

J

Faint

Very Light

Light

CLARITY

FL

IF

VVS¹⁻²

VS¹⁻²

SI¹⁻²

I¹⁻³

Flawless

Internally Flawless

Very Very Slightly Included

Very Slightly Included

Slightly Included

Included

LABORATORY GROWN DIAMOND REPORT

June 23, 2026

IGI Report Number

Description

Shape and Cutting Style

Measurements

LG811649083

LABORATORY GROWN DIAMOND

ROUND BRILLIANT

6.53 - 6.56 X 3.96 MM

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

Cut Grade

1.03 CARAT

D

VVS 1

IDEAL

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

Inscription(s)

EXCELLENT

EXCELLENT

NONE

IGI LG811649083

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

IGI



June 23, 2026

IGI Report No LG811649083

ROUND BRILLIANT

6.53 - 6.56 X 3.96 MM

Carat Weight

Color Grade

Clarity Grade

Cut Grade

Depth

Table

Girdle

Medium To Slightly Thick (Faceted)

Pointed

Polish

Symmetry

Fluorescence

Inscription(s)

1.03 CARAT

D

VVS 1

IDEAL

60.5%

66%

Medium To Slightly Thick (Faceted)

Pointed

EXCELLENT

EXCELLENT

NONE

IGI LG811649083

Comments: The Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

www.igi.org

© IGI 2020, International Gemological Institute

FD - 10 20

THIS DOCUMENT WAS PRODUCED WITH THE FOLLOWING SECURITY MEASURES: SPECIAL DOCUMENT PAPER, INK SCREENS, WATERMARK BACKGROUND DESIGNS, HOLOGRAM AND OTHER SECURITY FEATURES NOT LISTED AND DO EXCEED DOCUMENT SECURITY INDUSTRY GUIDELINES.

